

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/785,014	YO ET AL.	
Examiner	Art Unit	
John C. Hong	3726	

SEARCHED					
Class	Subclass	Date	Examiner		
29	407.08	10/31/2005	Du		
	407.05				
	407.01				
91	361				
	407				
	404				
	390				
219	89				

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
		DATE	EXMR
EAST		10/31/2005	Sh
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